

#3 DPA 7/31/01

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.:	Serial No.:
	1100.1116101 (H16-26635)	09/749,171
	Applicant:	
	Cabuz et al.	
	Filing Date	Group Art 1 2001
	12/27/2000	1765



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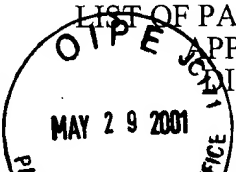
U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
AA	6,190,571	02/20/2001	Kato	216	2	
AB	6,125,700	10/03/2000	Tsugai et al.	73	504.12	
AC	6,092,417	07/25/2000	Yamamoto	73	504.04	
AD	6,089,089	07/18/2000	Hsu	73	504.12	
AE	6,089,088	07/18/2000	Charvet	73	504.12	
AF	6,087,747	07/11/2000	Dhuler et al.	310	90	
AG	6,067,858	05/30/2000	Clark et al.	73	504.16	
AH	5,992,233	11/30/1999	Clark	73	514.35	
AI	5,969,250	10/19/1999	Greiff	73	514.38	
AJ	5,914,801	06/22/1999	Dhuler et al.	359	230	
AK	5,894,090	04/13/1999	Tang et al.	73	504.02	
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AN	5,817,942	10/06/1998	Greiff	73	514.01	
AO	5,757,103	05/26/1998	Lee et al.	310	309	
AP	5,646,348	07/08/1997	Greiff et al.	73	514.36	
AQ	5,492,596	02/20/1996	Cho	156	632.1	
AR	5,490,420	02/13/1996	Burdess	73	504.02	
AS	5,329,815	07/19/1994	Dunn et al.	73	505	
AT	5,313,835	05/24/1994	Dunn	73	505	
AU	4,654,663	03/31/1987	Alsenz et al.	340	870.3	
AV	09/748,488		Cabuz et al.			12/27/2000

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DATE CONSIDERED: 1/9/02

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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Class	Translation Yes No
	AW						
	AX						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AY	J. Bernstein et al., "A Micromachined Comb-Drive Tuning Fork Rate Gyroscope," <u>Digest of IEEE/ASME MEMS Workshop</u> , pp. 143-148 (February 1993)
AZ	W. A. Clark et al., "Surface Micromachined X-Axis Vibratory Rate Gyroscope," <u>Proceedings of Solid State Sensor and Actuator Workshop</u> , pp. 283-287 (June 2-6, 1996)
BA	Dave Van Domelen, "The Coriolis Effect," http://www.physics.ohio-state.edu/~dvandom/Edu/coriolis.html , pp. 1-3 (1996)
BB	"Coriolis Effect," http://zebu.uoregon.edu/~js/glossary/coriolis_effect.html (dated on or before 12/27/2000)

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